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(to be used for all correspondence after initial filing)		Examiner Name	ROSASCO, STEPHEN D			
Total Number of Pages in This Submission		Attorney Docket Number	021653-0028	021653-002800US		
ENCLOSURES (Check all that apply)						
Amendment/F After Affida Extension of T Express Aban Information Di Certified Copy Document(s)	al Form Intrached Reply Final vits/declaration(s) Time Request donment Request sclosure Statement	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Add Terminal Disclaimer Request for Refund CD, Number of CD(s)	ess A A A A A A A A A A A A A A A A A A A	ppeal Co f Appeals ppeal Co ppeal Not roprietary tatus Lett ther Encl elow): ostcard	mmunication to TC mmunication to Board and Interferences mmunication to TC tice, Brief, Reply Brief) y Information ter losure(s) (please identify	
Reply	to Missing Parts 37 CFR 1.52 or 1.53	OF APPLICANT, ATTORN	FY OR AGEN	 		
Firm Name						
To	ownsend and Townsend and	d Crew LLP			22	
Signature						
Printed name Kent J. Tobin						
Date October 5, 2005		Reg. No	39,496	39,496		
CERTIFICATE OF TRANSMISSION/MAILING						
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.						
Signature Eleanar J. Taylor						
Typed or printed name Eleanor J. Tayl		l		Date	October 5, 2005	

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Mail Stop Amendment Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

On October 5, 2005

TOWNSEND and TOWNSEND and CREW LLP

D. Fleanar J. Vaylor

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Chi-Yuan Hung

Application No.: 10/701,035

Filed: November 3, 2003

For: METHOD AND STRUCTURE FOR FABRICATING PATTERNS ON PHASE SHIFT MASK FOR THE MANUFACTURE OF SEMICONDUCTOR WAFERS

Customer No.: 20350

Confirmation No. 6151

Examiner:

Stephen D. Rosasco

Technology Center/Art Unit: 1756

RESPONSE TO OFFICE ACTION

Mailed July 13, 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed July 13, 2005, please enter the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 8 of this paper.

Remarks/Arguments begin on page 12 of this paper.